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#3
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

JOHN J.ROSATO ET AL.

Appln. No. 09/408,279

Filed: September 29, 1999

For: PROCESS AND SYSTEM FOR
RINSING OF SEMICONDUCTOR
SUBSTRATES



Group Art Unit: 1751

Examiner:

**PETITION FOR A ONE (1) MONTH EXTENSION
OF TIME TO RESPOND**

2001 Ferry Building
San Francisco, CA 94111
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I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail
in an envelope addressed to: Assistant Commissioner
for Patents, Washington, DC 20231
on JANUARY 13, 2000

LIMBACH & LIMBACH, L.L.P.

Dated: JAN 13 2000

By:

Name

Norma E. Gillespie

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant hereby petitions for a one (1) month extension of time to answer the
outstanding Official Action mailed October 26, 1999 regarding the above-referenced patent
application. Please find enclosed a check in the amount of \$110.00 to cover the extension fee.

The Commissioner is hereby authorized to charge payment of any fees associated with
this communication or credit any overpayment to Deposit Account No. 12-1420. A duplicate
copy of this sheet is enclosed.

Respectfully submitted,

LIMBACH & LIMBACH L.L.P.

By:

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Registration No. 24,307

Attorneys for Applicant(s)

January 13, 2000
(Date)

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